



**ELECTRONIC COPY**

LG747529922  
Report verification at igi.org



November 27, 2025

IGI Report Number **LG747529922**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **BAGUETTE CUT**

Measurements **8.92 X 4.13 X 2.32 MM**

**GRADING RESULTS**

Carat Weight **1.03 CARAT**

Color Grade **F**

Clarity Grade **VVS 1**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

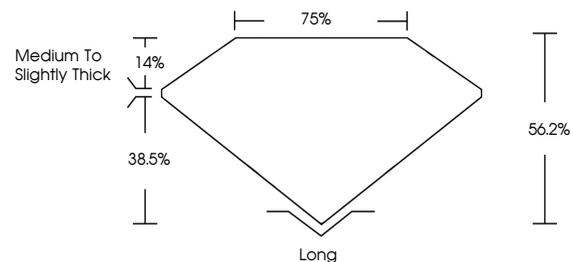
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG747529922**

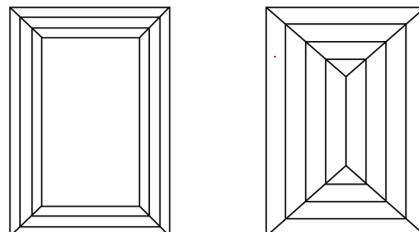
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

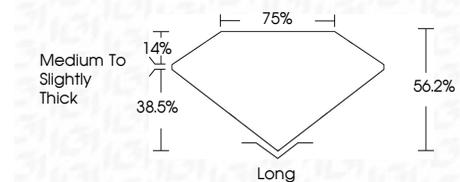
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Symmetry **EXCELLENT**

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**IGI**



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**BAGUETTE CUT**  
**8.92 X 4.13 X 2.32 MM**  
Carat Weight **1.03 CARAT**  
Color Grade **F**  
Clarity Grade **VVS 1**  
Depth **56.2%**  
Table **75%**  
Girdle **Medium to Slightly Thick**  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG747529922**  
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Type IIa